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APPLICANTS Hiroyuki Ito, Narita-shi, JAPAN;				
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** FOREIGN APPLICATIONS ***** JAPAN P2002-206038 07/15/2002				
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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance		STATE OR COUNTRY JAPAN	SHEETS DRAWING 4	TOTAL CLAIMS 9
Verified and Acknowledged <i>Examiner's Signature</i> <i>GS</i> Initials		INDEPENDENT CLAIMS 1		
ADDRESS Keith M. Tackett MOSER, PATTERSON & SHERIDAN, L.L.P. Suite 1500 3040 Post Oak Blvd. Houston, TX 77056				
TITLE Ion implantation method and method for manufacturing SOI wafer				
FILING FEE RECEIVED 750	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	